IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of: Fair et al.

Attorney Docket No.:

NOVLP067D2/NVLS-000376D2

Application No.: NEW

Examiner: UNASSIGNED

Filed: HEREWITH

Group: UNASSIGNED

Title: SEQUENTIAL ELECTRON INDUCED

CHEMICAL VAPOR DEPOSITION

PRELIMINARY AMENDMENT

Mail Stop Patent Application Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Dear Sir:

Before examination on its merits, please amend the above-identified patent application as follows:

Amendments to the Specification begin on page 3 of this paper.

Remarks/Arguments begin on page 3 of this paper.